

#7/BAA  
1-9-01  
Harrison

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re United States Patent Application of:

Applicants: Peter Van Buskirk, et al.

Application No.: 09/200,495

Date Filed: November 25, 1998

Title: **OXIDATIVE TOP ELECTRODE DEPOSITION  
PROCESS, AND MICROELECTRONIC DEVICE  
STRUCTURE**

Docket No.: 2771-337

Examiner: S. Hu

Art Unit: 2811


**FACSIMILE TRANSMISSION CERTIFICATE**

I hereby certify that I am filing this document in the United States Patent and Trademark Office on January 3, 2001, by facsimile transmission, addressed to the Commissioner for Patents, BOX AF, Washington, DC 20231, and facsimile transmitted to U.S. PTO Group 2800 facsimile machine at (703) 308-7722. Number of pages transmitted: 9 pages.

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**TECHNOLOGY CENTER 2800**

  
Steven J. Hultquist

**PLEASE IMMEDIATELY HAND-DELIVER TO EXAMINER SHOUXIANG HU  
(TELEPHONE: (703) 306-5729)**

**AMENDMENT RESPONDING TO OCTOBER 3, 2000 OFFICE ACTION IN U.S.  
PATENT APPLICATION NO. 09/200,495**

Commissioner for Patents  
BOX AF  
Washington, D.C. 20231

Sir:

In response to the April 21, 2000 Office Action in the above-identified patent application, please amend the application as follows: